

FORM PTO-1449
(Modified)

APR 27 2001

U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No.: SSI-00700

Serial No.: 09 704,641

INFORMATION DISCLOSURE STATEMENT BY APPLICANT
(Use Several Sheets If Necessary)

(37 CFR § 1.98(b))

Applicant: Maximilian A. Biberger et al.

Filing Date: November 1, 2000

Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initials		Serial Patent Number	Issue Date	Applicant Patentee	Class	Subclass	Filing Date
12	AA	5,866,005	02/02/99	DeSimone et al.	210	634	11/1/96
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
	AO						
	AP						

FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

		Document Number	Publication Date	Country Patent Office	Class	Subclass	Translation	
							Yes	No
	AQ	EP 0 836 895 A2	04/22/98	EP	B08B	7/00	X	
	AR	WO 99/49998	10/07/99	WO	B08B	5/00	X	
	AS							

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

	AT	"A Comparison of Chilled DI Water, Ozone and CO ₂ -Based Supercritical Fluids as Replacements for Photoresist-Stripping Solvents" by J.B. Rubin et al., Physical Organic Chemistry Group (CST-12) Chemical Science & Technology Division Los Alamos National Laboratory, Los Alamos, New Mexico.					
	AU						
	AV						
	AW						
	AX						
	AY						
	AZ						

Examiner:

Rosen

Date Considered:

3-28-2002

EXAMINER:

Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449
(Modified)

APR 18 2001

U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No. SSI-00700

Serial No. 09 704,641

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use Separate Sheets If Necessary)

(37 CFR § 1.98(b))

Applicant: Biberger et al.

Filing Date: 11-01-00

Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initials		Serial Patent Number	Issue Date	Applicant Patentee	Class	Subclass	Filing Date
✓	AA	5,965,025	10-12-99	War et al.	210	634	1-21-98
✓	AB	5,888,050	3-30-99	Fitzgerald et al.	417	46	8-25-98
✓	AC	5,797,719	8-25-98	James et al.	417	46	10-30-96
✓	AD	5,730,874	3-24-98	War et al.	210	638	6-2-94
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

		Document Number	Publication Date	Country Patent Office	Class	Subclass	Translation	
							Yes	No
	AK							
	AL							
	AM							
	AN							
	AO							

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

	AP	
	AQ	
	AR	
	AS	
	AT	
	AU	
	AV	
	AW	
	AX	
	AY	
	AZ	

Examiner:

Lawrence

Date Considered:

3-28-2002

EXAMINER:

Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1419
(Modified)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No.: SSI-00700

Serial No.: 09 704,641

INFORMATION DISCLOSURE STATEMENT BY APPLICANT
(Use Several Sheets If Necessary)

(37 CFR § 1.98(b))

Applicant: Maximilian A. Biberger *et al.*

Filing Date: November 1, 2000

Group Art Unit: 2812

U.S. PATENT DOCUMENTS

Examiner Initials		Serial Patent Number	Issue Date	Applicant Patentee	Class	Subclass	Filing Date
	AA	4,592,306	06/03/86	Gallego	118	719	11/30/84
	AB	4,670,126	06/02/87	Messer <i>et al.</i>	204	298	04/28/86
	AC	4,825,808	05/02/89	Takahashi <i>et al.</i>	118	719	07/08/87
	AD	4,951,601	08/28/90	Maydan <i>et al.</i>	118	719	06/23/89
	AE	5,934,856	08/10/99	Asakawa <i>et al.</i>	414	217	04/28/97
	AF	6,077,321	06/30/00	Adachi <i>et al.</i>	29	25 01	11/07/97

FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

		Document Number	Publication Date	Country Patent Office	Class	Subclass	Translation	
							Yes	No
	AG	EP 0 244 951 A2	11/11/87	EP	H 01 L	21 00		x
	AH	EP 0 272 141 A2	06/22/88	EP	H 01 L	21 00		x
	AI	GB 2 193 482 A	02/10/88	GB	B 25 J	18 02		x
	AJ	JP 10-144757	05/29/98	JP	H 01 L	21 68		x
	AK	JP 56-142629	11/07/81	JP	H 01 L	21 205		x
	AL	JP 60-238479	11/27/85	JP	C 23 C	14 56	x	
	AM	JP 60-246635	12/06/85	JP	H 01 L	21 302		x
	AN	JP 61-231166	10/15/86	JP	C 23 C	14 24		x
	AO	JP 63-303059	12/09/88	JP	C 23 C	14 22		x
	AP	WO 87 07309	12/03/87	WO	C 23 C	16 00		x
	AQ	WO 91 12629	08/22/91	WO	H 01 L	21 00		x
	AR	WO 99 186603	04/15/99	WO	H 01 L	21 00		x

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

AS	Hideaki Itakura <i>et al.</i> , "Multi-Chamber Dry Etching System", Solid State Technology, April 1982, pp. 209-214.
AT	
AU	
AV	
AW	
AX	
AY	

Examiner

Kenneth

Date Considered

3-28-2002

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